Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

- 1. (original) A method of applying patterned materials for manufacture of a flat panel light source, comprising:
 - a) providing a flexible continuous substrate;
- b) providing one or more application stations, each application station having:
 - i) one or more stationary sources of material,
- ii) a supply of discrete patterned masks for defining a pattern of material to be applied to the substrate,
- iii) means for attaching the discrete patterned masks to the substrate;
- iv) means for transporting the substrate and the patterned mask in registration past the one or more stationary sources of material, and
- v) means for delivering the masks one at a time to the transporting means; and
- c) transporting the substrate and the masks past the one or more application stations.
- 2. (original) The method claimed in claim 1, wherein the stationary source is a linear source arranged orthogonal to the direction of transport.
- 3. (original) The method claimed in claim 1, wherein the stationary sources are arranged in parallel with respect to the direction of transport.
- 4. (original) The method claimed in claim 1, wherein the application stations are arranged in parallel with respect to the direction of transport.

- 5. (original) The method claimed in claim 1, wherein the light source is an OLED light source.
- 6. (original) The method claimed in claim 1, wherein the materials are light emissive materials, semiconductor materials, conductors, or dielectrics.
- 7. (original) The method claimed in claim 1, wherein the mask is a rigid sheet.
- 8. (original) The method claimed in claim 1, wherein the mask is a flexible sheet.
- 9. (original) The method claimed in claim 1, further comprising the steps of cleaning material from the masks and reusing the masks.
- 10. (original) A flat panel light source made by the method of claim 1.
- 11. (original) The method claimed in claim 1, wherein the masks are discarded after a single use.
- 12. (original) The method claimed in claim 1, wherein the substrate is a web mounted on a supply roller located on one side of the application station(s).
- 13. (original) The method claimed in claim 1, further comprising the step of cutting the substrate into sheets after deposition of the material.
- 14. (original) The method claimed in claim 1, wherein the stationary sources are arranged in parallel with respect to the direction of transport.

- 15. (original) The method claimed in claim 1, further comprising the step of shifting the mask relative to the substrate in a direction perpendicular to the direction of transport between sources.
- 16. (original) The method claimed in claim 1, wherein the mask is a magnetic material and the means for attaching the mask to the substrate is a magnet located on an opposite side of the substrate from the mask.
- 17. (original) The method claimed in claim 16, wherein the means for attaching the mask includes a reference surface for locating the substrate with respect to the source of material.
- 18. (original) The method claimed in claim 16, wherein the magnet is a fixed magnet.
- 19. (original) The method claimed in claim 16, wherein the magnet is conveyed along with the substrate.
- 20. (original) The method claimed in claim 1, wherein the means for attaching the mask to the substrate is a mechanical clamp.
- 21. (original) The method claimed in claim 20, wherein the mechanical clamp includes means for maintaining the substrate in a planar configuration.
- 22. (currently amended) The method claimed in claim 4 20, wherein the mechanical clamp includes a rectangular frame having clamps on two opposing edges.
- 23. (original) The method claimed in claim 1, further comprising the step of displacing the mask in a direction orthogonal to the direction of transport of the substrate between application stations.

- 24. (withdrawn) Apparatus for applying patterned materials to a flexible continuous substrate for manufacture of a flat panel light source, comprising:
- a) one or more application stations, each application station having:
 - i) one or more stationary sources of material.
- ii) a supply of discrete patterned masks for defining a pattern of material to be applied to the substrate,
- iii) means for attaching the discrete patterned masks to the substrate;
- iv) means for transporting the substrate and the patterned mask in registration past the one or more stationary sources of material, and
- v) means for delivering the masks one at a time to the transporting means; and
- b) means for transporting the substrate and the masks past the one or more application stations.
- 25. (withdrawn) The apparatus claimed in claim 24, wherein the stationary source is a linear source arranged orthogonal to the direction of transport.
- 26. (withdrawn) The apparatus claimed in claim 24, wherein the stationary sources are arranged in parallel with respect to the direction of transport.
- 27. (withdrawn) The apparatus claimed in claim 24, wherein the application stations are arranged in parallel with respect to the direction of transport.
- 28. (withdrawn) The apparatus claimed in claim 24, wherein the light source is an OLED light source.

- 29. (withdrawn) The apparatus claimed in claim 24, wherein the materials are light emissive materials, semiconductor materials, conductors, or dielectrics.
- 30. (withdrawn) The apparatus claimed in claim 24, wherein the mask is a rigid sheet.
- 31. (withdrawn) The apparatus claimed in claim 24, wherein the mask is a flexible sheet.
- 32. (withdrawn) The apparatus claimed in claim 24, further comprising the steps of cleaning material from the masks and reusing the masks.
- 33. (withdrawn) The apparatus claimed in claim 24, wherein the masks are discarded after a single use.
- 34. (withdrawn) The apparatus claimed in claim 24, wherein the substrate is a web mounted on a supply roller located on one side of the application station(s).
- 35. (withdrawn) The apparatus claimed in claim 24, further means for cutting the substrate into sheets after deposition of the material.
- 36. (withdrawn) The apparatus claimed in claim 24, wherein the stationary sources are arranged in parallel with respect to the direction of transport.
- 37. (withdrawn) The apparatus claimed in claim 24, further comprising means for shifting the mask relative to the substrate in a direction perpendicular to the direction of transport between sources.
- 38. (withdrawn) The apparatus claimed in claim 24, wherein the mask is a magnetic material and the means for attaching the mask to the substrate is a magnet located on an opposite side of the substrate from the mask.

- 39. (withdrawn) The apparatus claimed in claim 38, wherein the means for attaching the mask includes a reference surface for locating the substrate with respect to the source of material.
- 40. (withdrawn) The apparatus claimed in claim 38, wherein the magnet is a fixed magnet.
- 41. (withdrawn) The apparatus claimed in claim 38, wherein the magnet is conveyed along with the substrate.
- 42. (withdrawn) The apparatus claimed in claim 24, wherein the means for attaching the mask to the substrate is a mechanical clamp.
- 43. (withdrawn) The apparatus claimed in claim 42, wherein the mechanical clamp includes means for maintaining the substrate in a planar configuration.
- 44. (withdrawn) The method claimed in claim 24, wherein the mechanical clamp includes a rectangular frame having clamps on two opposing edges.
- 45. (withdrawn) The apparatus claimed in claim 24, further means for displacing the mask in a direction orthogonal to the direction of transport of the substrate between application stations.